

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the **PATENT APPLICATION** of:

John E. Campo et al.

Application No.: 10/579,002

Our File: NPS-PT007.1US

Confirmation No.: 4507

Date: January 16, 2008

Filed: 05/11/2006

For: PROJECTILE, PROJECTILE CORE,
AND METHOD OF MAKING

Group: 3641

Examiner: Not Yet Known

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Further to Applicant's Duty of Disclosure pursuant to 37 C.F.R. §1.56, Applicant wishes to bring to the Examiner's attention the material cited on the enclosed PTO-1449 form.

Pursuant to 37 C.F.R. §1.98(a)(2)(ii), copies of the cited U.S. publications and/or patent documents have not been included.

This Information Disclosure Statement is being filed before the first office action on the merits in this case. No fee is believed to be due. If any fee is due, please charge Deposit Account no. 22-0493.

Applicant: John E. Campo et al.

Application No.: 10/579,002

It is respectfully requested that the Examiner consider these documents and return an initialed copy of the PTO-1449 form indicating his or her consideration of the cited materials.

Respectfully submitted,

John E. CAMPO et al.

By /Michael F. Snyder/

Michael F. Snyder

Registration No. 58,347

Volpe and Koenig, P.C.
United Plaza, Suite 1600
30 South 17th Street
Philadelphia, PA 19103
Telephone: (215) 568-6400
Facsimile: (215) 568-6499
MFS/mds
Enclosures